

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application Serial No	34
Filing Date April 3, 200	01
Inventor David R. Hembro	eе
Assignee Micron Technology, Ir	
Group Art Unit	58
Examiner V. Nguye	en
Attorney's Docket No MI22-168	30
Title: Electronic Device Wafer Processing Members and Wafer Processing Apparatuse	es

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: (0 6 03

Attorney:

James D. Shaurette Reg. No. 39,833

TECHNOLOGY CENTER 2800

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No		
Filing Date		April 3, 2001
Inventor		David R. Hembree
Assignee		. Micron Technology, Inc.
Group Art Unit		2858
Examiner		V. Nauven
Attorney's Docket No		MI22-1680
Title:	An Electronic Device Workp	iece Processing Member

# SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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Respectfully submitted,

Dated: 3 25 03

Attorney:

James D. Shaurette

Reg. No. 39,833

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### IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No	
Filing Date	April 3, 2001
Inventor	David R. Hembree
Assignee	Micron Technology, Inc.
Group Art Unit	
Examiner	V. Nguyen
Attorney's Docket No	Ml22-1680
Title:	An Electronic Device Workpiece Processing Member

#### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

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Respectfully submitted,

Attorney:

James D. Shaurette

Reg. No. 39,833

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